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CONFIRMATION NO. 2419

<b>SERIAL NUMBER</b> 10/540,720	<b>FILING OR 371(c) DATE</b> 01/13/2006 <b>RULE</b>	<b>CLASS</b> 438	<b>GROUP ART UNIT</b> 2812	<b>ATTORNEY DOCKET NO.</b> 450101-04870.1
<b>APPLICANTS</b> Koichiro Kishima, Kanagawa, JAPAN; Prakash Koonath, Los Angeles, CA;				
<b>** CONTINUING DATA *****</b> This application is a 371 of PCT/JP04/16188 10/25/2004 which claims benefit of 60/514,379 10/24/2003				
<b>** FOREIGN APPLICATIONS *****</b>				
Foreign Priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance Verified and Acknowledged _____ Examiner's Signature _____ Initials _____		<b>STATE OR COUNTRY</b> JAPAN	<b>SHEETS DRAWING</b> 10	<b>TOTAL CLAIMS</b> 20
		<b>INDEPENDENT CLAIMS</b> 4		
<b>ADDRESS</b> William Frommer Frommer Lawrence & Haug 745 Fifth Avenue New York ,NY 10151				
<b>TITLE</b> Method for manufacturing semiconductor substrate and semiconductor substrate				
<b>FILING FEE RECEIVED</b> 1230	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit	